



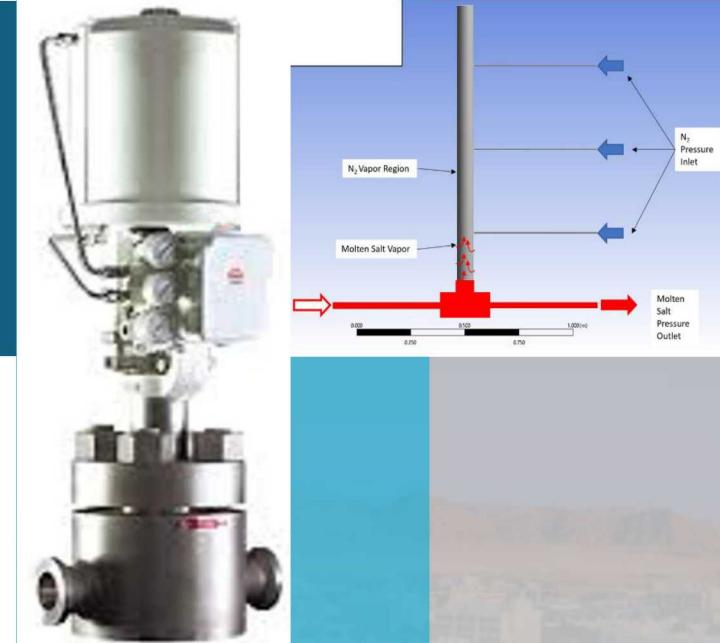
# Vapor Transport Analysis of a Chloride Molten Salt Flow Control Valve

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# Agenda



## Objectives

- Thermal-fluid flow phenomena investigation of proportional flow control valve (FCV) for 750 °C high-temperature transport.
- Computational Fluid Dynamics (CFD) model to accurately characterize salt vapor plating phenomena within valves.

## Overview

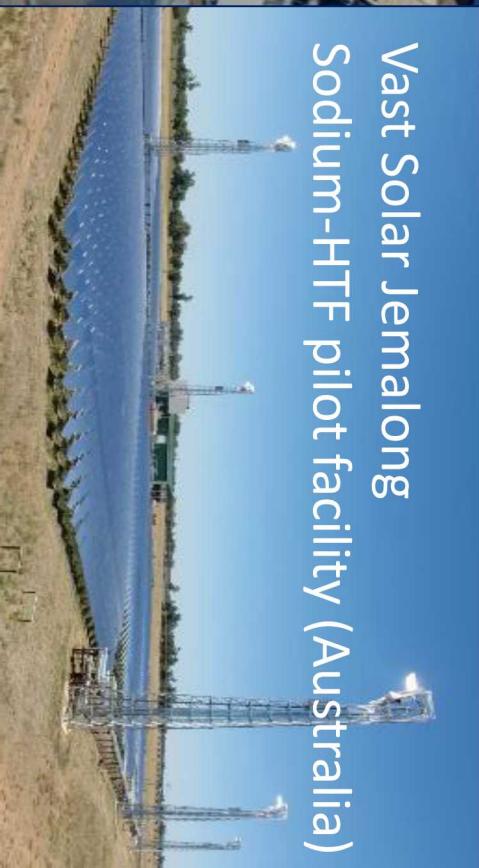
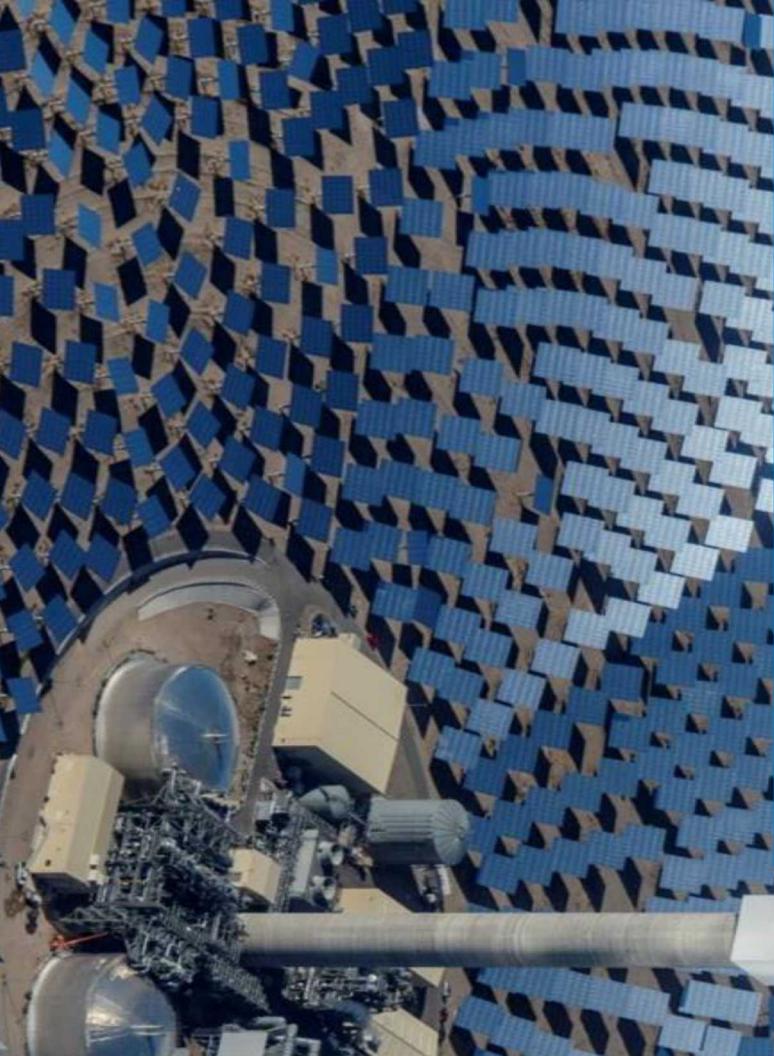
- Advanced valve for the DOE Gen 3 Liquid-Pathway program.
- Chloride molten salt vapor plating challenges related to valves.
- Model development.
- Modelling analysis results.

## Conclusions & Future work

# Gen3 Liquid Pathway

- Leverage expertise with liquid-HTF
- Examine two, high-temp liquids
- Use low-cost, thermally stable energy storage media
- Design for sCO<sub>2</sub>, Brayton-cycle integration

**SolarReserve Crescent Dunes  
Molten-salt HTF plant (USA)**



# Next Gen Chloride Salt



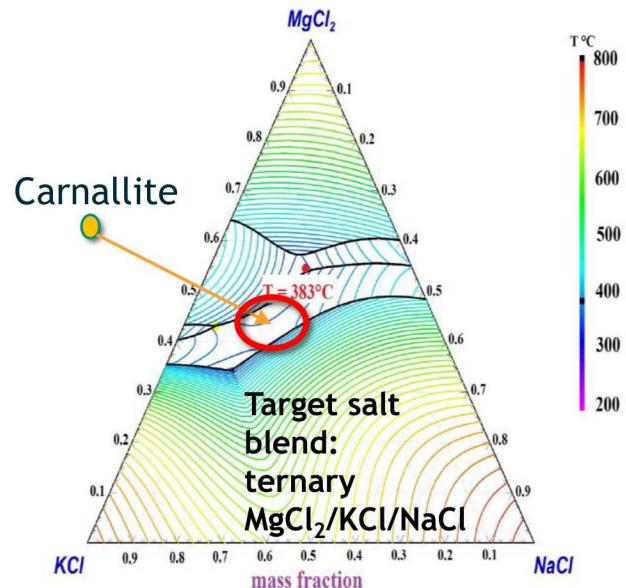
- Limit of traditional solar-salt thermal stability is  $\sim 600$  °C with ambient air as cover gas.
- Nitrate salt concentrating solar power (CSP) systems currently deployed are considered state-of-the art heat transfer fluids (HTFs)
- To achieve \$15/kWh HTFs and LCOE of 6¢/kWh, need technologies at higher temperatures (e.g., 650 °C to 750 °C) with alternative salt chemistry composition.

## Salt Vapor Composition

- Although salt vapor product melting temps are high, carnallite ( $\text{KMgCl}_3$ ) is relatively low.

| Gaseous Molecule | Molecular Mass [g/mol] | Melting Temperature [°C] | Diffusivity [ $\text{m}^2/\text{s}$ ] | Reference            |
|------------------|------------------------|--------------------------|---------------------------------------|----------------------|
| $\text{KMgCl}_3$ | 169.76                 | 480                      | 2.38E-05                              | TOMÁŠEK et al., 2017 |
| NaCl             | 58.44                  | 797                      | 7.45E-05                              | ZHOU et al., 2020    |
| KCl              | 74.55                  | 768                      | 4.62E-05                              | ZHOU et al., 2020    |
| $\text{MgCl}_2$  | 95.211                 | 714                      | 6.85E-05                              | PENG et al., 2016    |

Carnallite:  
 $\text{MgKCl}_3 \cdot 6\text{H}_2\text{O}$

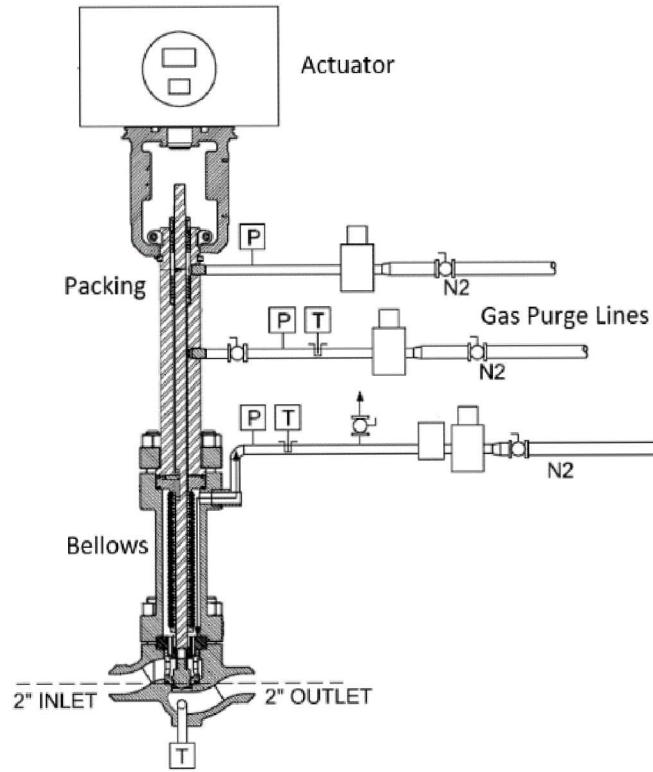


Mohan et al., Energy Conversion and Management 167 (2018)

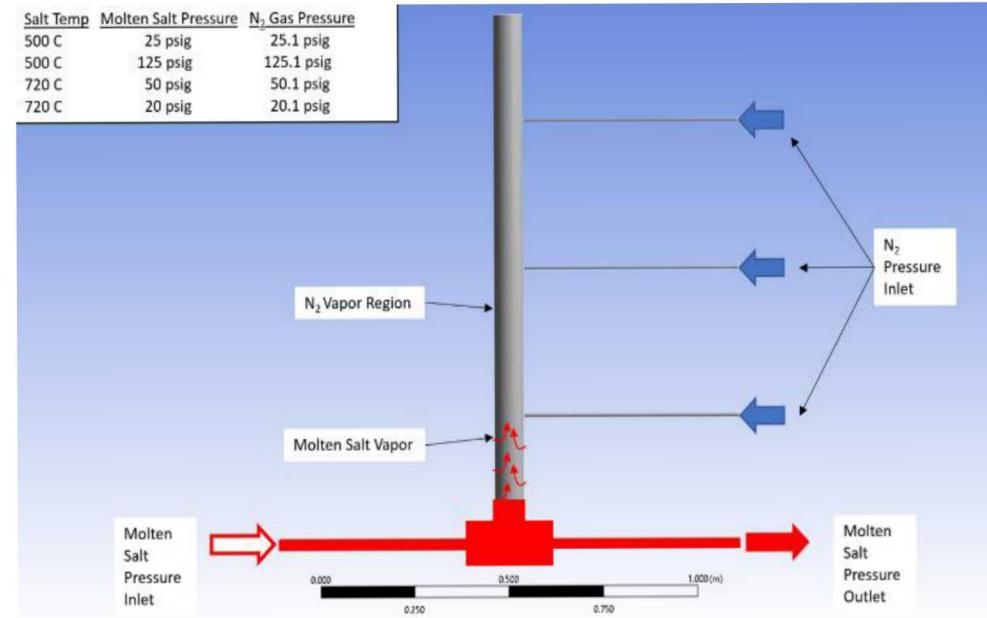
# Proportional Control Valve Design



- FCV's required to modulate flow through CSP systems to facilitate transient (e.g. receiver preheating & drain-back) and steady operations (e.g. TES charging/discharging).
- FCV plug design offers a target  $C_v$  curve for nominal flow control.
- Proper flow control is critical for flow management when operating pumps, attemporation and rapid drain-back operations.
- Chloride salt valves require ullage gas input to mitigate air ingress, reduce liq./vap. salt transport.
- Challenge: salt vapors may penetrate beyond bellows seal to narrow areas and facilitate plating.



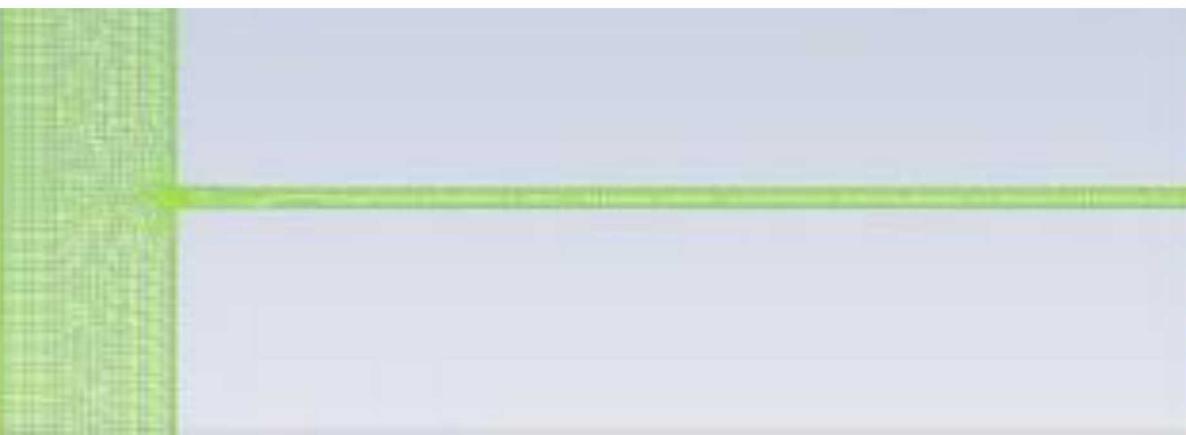
| Salt Temp | Molten Salt Pressure | N <sub>2</sub> Gas Pressure |
|-----------|----------------------|-----------------------------|
| 500 C     | 25 psig              | 25.1 psig                   |
| 500 C     | 125 psig             | 125.1 psig                  |
| 720 C     | 50 psig              | 50.1 psig                   |
| 720 C     | 20 psig              | 20.1 psig                   |



# Model Setup



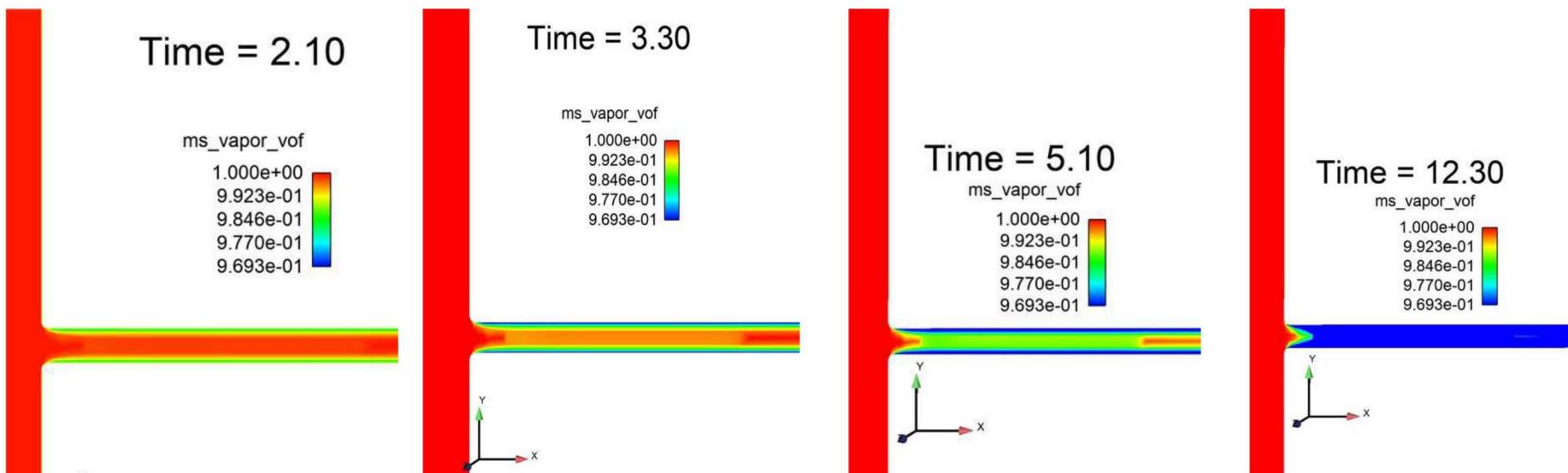
- Two-part phase change model: Gas/Liquid Multiphase Volume of Fluid Model & & Liquid/Solid Solidification Model
  - Considering vapor condensing and plating in ullage lines during a contingency ( $N_2$  gas reduction less than salt vapor pressure).
  - **Four Submodels:** 1. Energy, 2. Laminar Fluid dynamics, 3. Multiphase Volume of Fluid (2 Eulerian Phases) & 4. Solidification & Melting Model.
- Heat losses allowed on the  $N_2$  lines (1/4" ID) to simulate contingency power loss.
- Inlet saturated salt vapor condition  $\sim 0.01$  m/s (to approximate Laminar BC) and adiabatic wall valve boundary conditions, and no-slip BC at the walls.
- Inflation layers added to Mesh to capture boundary layer flow dynamics within valve.
- Transient Simulation with a fixed 0.3 sec. therefore Courant Number  $< 1$  (CFD flow dynamics convergence criteria).



# System Results (Vapor/Liquid)



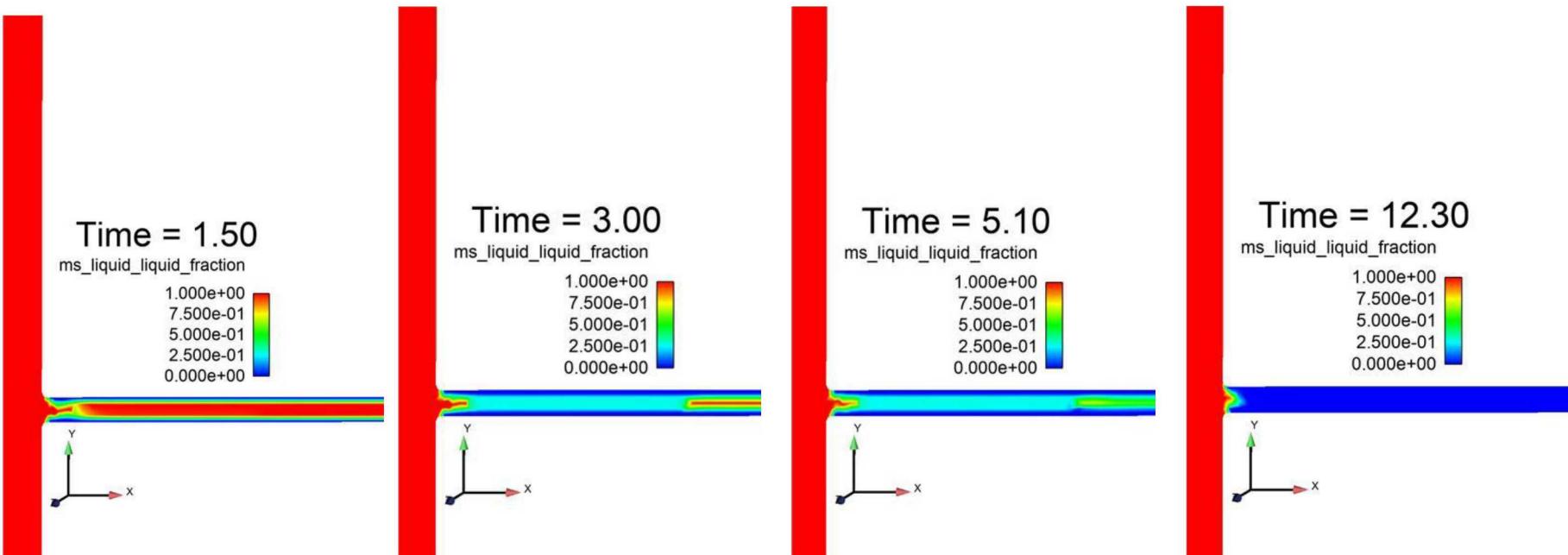
- Fully developed flow indicated by constant steady velocity flow profile.
- With reduction in temperature placed on  $N_2$  gas line boundary, gas (red) / liquid (blue) phase change observed with VOF model.
- Vapor to liquid phase change found to begin completely occupying gas line at 3.3 sec.
- As phase change occurs vapor velocity reduces at gas line interface  $\sim 1$  in. from piping intersection.
- Molten salt vapor would only occupy small volume fraction because of small partial pressure within total gas mixture.



# System Results (Liquid/Solid)



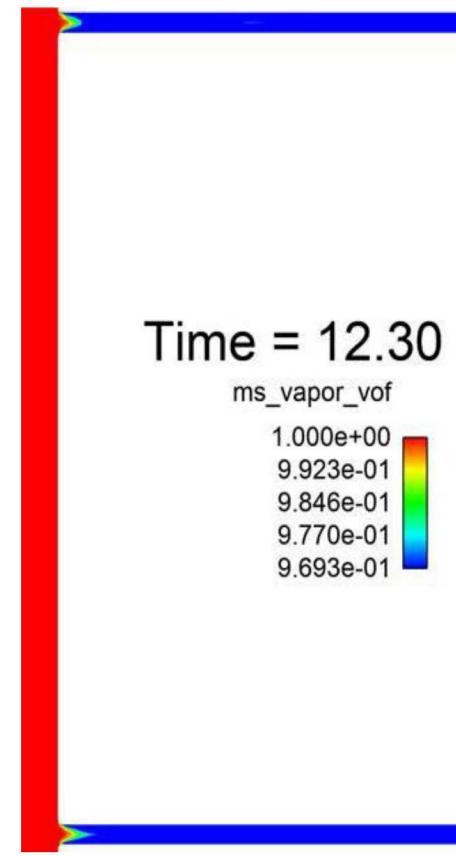
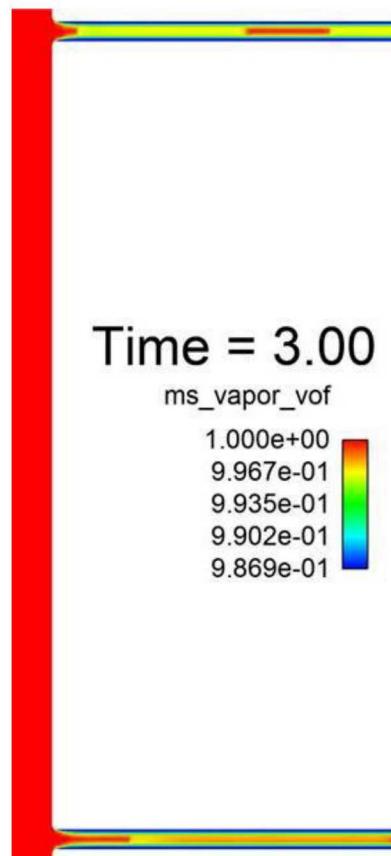
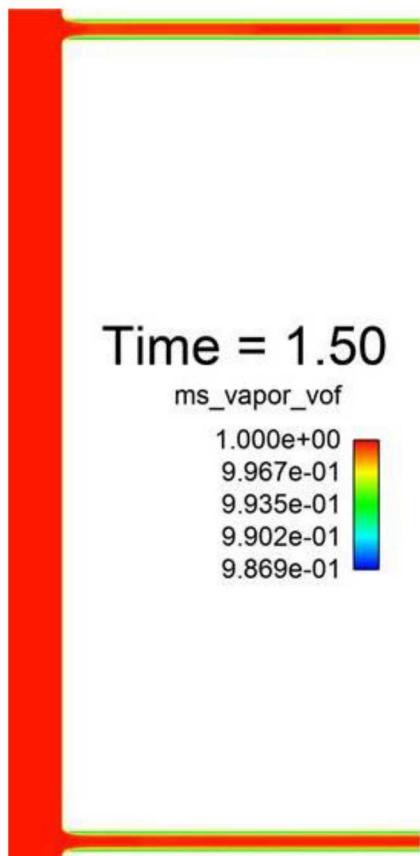
- Red region indicates non-solid (either gas or liquid)
- Molten salt vapor would only occupy a small volume fraction, because of the small partial pressure within the gas mixture.
- Partial pressure of salt vapors (based on concentrations) determine the phase it can be stable at.
- From the solidification model results, one can see confirmed velocity reduction to zero corresponding to solidification of the previous VOF liquid phase, indicating plating phenomena.



# System Results



- Slightly higher velocity found on bottom  $N_2$  line than with top line due to friction losses.
- Higher velocities indicate lower solidification potential.
- $N_2$  gas velocity (even slight) would increase the salt vapor velocities further reducing the potential for plating.
- Overall loss of  $N_2$  ullage gas pressure and heating power would result in near-immediate plating/plugging of lines with salt vapor.



# Conclusions & Future Work



- Worst case, 1<sup>st</sup> Order CFD model of loss in N<sub>2</sub> ullage gas in valve system.
- Analysis considers volume fractions to assess plating phenomena.
  - If a particular salt vapor product has high concentration then its particular partial pressure can be higher, which encourages higher plating phenomena.
- Overall loss of N<sub>2</sub> ullage gas pressure and heating power would result in near-immediate plating/plugging of lines with salt vapor
- N<sub>2</sub> gas velocity (even slight) would increase the salt vapor velocities further reducing the potential for plating.
  - If vapors reach a point that they slow down, then plating potential increases.
- Future work to consider partial N<sub>2</sub> gas loss due to fouling.
- Classical thermodynamics model evaluating macroscopic gas dynamics and phase change.
- Statistical thermodynamics is needed to capture species interactions between product salt vapors and N<sub>2</sub> gas to fully understand psychometric properties and gas/phase change dynamics.

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# Thank you.

